

INFORMATION DISCLOSURE STATEMENT	Application No.: 10/822,891	Sheet 1 of 1
	Docket No.: SNY-T5707.02	Group: 2423
	Filed: 04/13/2004	Conf. No.: 4007
	Applicant: Candelore et al.	



U.S. PATENT DOCUMENTS					
Exam. Init.	Document Number	Issue/Pub. Date	Name	Class	Filing Date
/A.C./	5,159,633	10/27/1992	Nakamura		01/15/1991
/A.C./	2003/0152232	08/14/2003	Pirila et al.		6/25/2001
/A.C./	2007/0006253	01/04/2007	Pinder et al.		06/29/2005
/A.C./	7,490,236	02/10/2009	Wasilewski		01/14/2004
/A.C./	7,496,198	02/24/2009	Pinder et al.		12/06/2005
/A.C./	7,555,123	06/30/2009	Pinder et al.		04/29/2005

FOREIGN PATENT DOCUMENTS					
Exam. Init.	Document Number	Date	Country	Class	Translation
/A.C./	JP 61-264371	11/22/1986	Japan		Yes**

** Partial translation submitted in IDS 4/6/2010.

OTHER DOCUMENTS / CITATIONS	
Exam. Init.	Document

Examiner: /Alfonso Castro/	Date: 07/29/2010
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APPENDIX

These references are cited in one or more applications related to this patent application in US Office Actions. In some instances, art cited in this and other IDS may not constitute prior art to the present application. Below is a list of references received with reference to the corresponding application number.

Document Number	Issue/Pub. Date	Name	Filing Date	Disclosure from
2003/0152232	08/14/2003	Pirila et al.	06/25/2001	US Application No. 11/891,209
7,490,236	02/10/2009	Wasilewski	01/14/2004	US Application No. 11/526,316
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JP 61-264371	11/22/1986			JP Application No. 2004-534603 related to US 7,120,250